



Attorney Docket No.: 002818/PDD/PSI/MBE

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Suketu A. Parikh ✓

Serial No.: 09/244,788 ✓

Filed: 2/5/99 ✓

For: Dual Damascene Misalignment  
Tolerant Techniques For Vias And  
Sacrificial Etch Segments ✓

) Group:  
) Art Unit: 2811  
) Examiner:  
)  
) TRANSMITTAL LETTER  
)  
) PATENT COUNSEL  
) APPLIED MATERIALS, INC.  
) Legal Affairs Department  
) P.O. Box 450 A  
) Santa Clara, CA 95052

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

TRANSMITTAL OF FORMAL DRAWINGS

Enclosed please find twenty one (21) sheets of formal drawings for the above-identified patent application.

Respectfully submitted,

Dated:

8/9/99

By:

Robert W. Mulcahy  
Reg. No.: 25,436

RECEIVED  
AUG 13 1999  
22800 MAIL ROOM

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope to: Assistant Commissioner for Patents, Washington, D.C. 20231

Express Mail Receipt No. E426634074245

Date of Deposit 8/9/99

Signature

Robert W. Mulcahy